



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Crocifisso Marco Antonio RENNA, Luigi LA MAGNA, Simona LORENTI, and Salvatore COFFA

Title: MANUFACTURING METHOD FOR A SEMICONDUCTOR SUBSTRATE COMPRISING AT LEAST A BURIED CAVITY AND DEVICES FORMED WITH THIS METHOD

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CERTIFICATE OF MAILING OR TRANSMISSION

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Signature

AMENDMENT AND RESPONSE UNDER 37 CFR §1.111

TO THE COMMISSIONER FOR PATENTS

Please reconsider the above-referenced patent application in view of the following amendments and remarks:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.